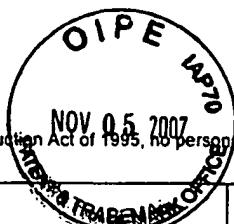


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( Not for submission under 37 CFR 1.99)

Application Number	10645773
Filing Date	2003-08-21
First Named Inventor	Hidehiko Kawaguchi
Art Unit	1746 1792
Examiner Name	B. S. Carrillo
Attorney Docket Number	KAMMON 3.0-069 CONT

### U.S.PATENTS

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1 /SC/	1	11082504	JP		1999-03-26	Nippon Seiko Kk		<input checked="" type="checkbox"/>
2 /SC/	2	60034612	JP		1985-02-22	Toray Industries		<input checked="" type="checkbox"/>
3	3	62280700	JP		1987-12-05	Hitachi Ltd	<i>not considered no relevance or translation provided.</i>	<input type="checkbox"/>

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>( Not for submission under 37 CFR 1.99)</i>		Application Number	10645773
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		Examiner Name	B. S. Carrillo
		Attorney Docket Number	KAMMON 3.0-069 CONT

4	/SC/	4	19738147	DE		1999-03-04	Steag Micro Tech Gmbh	<input checked="" type="checkbox"/>
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Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.	T5 <input type="checkbox"/>
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Examiner Signature	/Sharidan Carrillo/	Date Considered	12/31/2007
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